AIDA-SLIDE-2015-022

AIDA

Advanced European Infrastructures for Detectors at Accelerators

Presentation

Development of technological prototype of silicon-tungsten electromagnetic calorimeter for ILD

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02 June 2014



The research leading to these results has received funding from the European Commission under the FP7 Research Infrastructures project AIDA, grant agreement no. 262025.

This work is part of AIDA Work Package 9: Advanced infrastructures for detector R&D.

The electronic version of this AIDA Publication is available via the AIDA web site <http://cern.ch/aida> or on the CERN Document Server at the following URL: <http://cds.cern.ch/search?p=AIDA-SLIDE-2015-022>



Development of a technological prototype of Silicon-Tungsten electromagnetic calorimeter for ILD

Vincent Boudry LLR – École polytechnique







TIPP'2014 Amsterdam June 2nd-6th, 2014



東京大学



Grant ANR-2010-0429-01



ILC parameters



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Constrains on detectors:

Basis: sep of H \rightarrow WW/ZZ \rightarrow 4j - $\sigma_Z/M_Z \sim = \sigma_W/M_W \sim = 2.7\% \oplus 2.75\sigma_{sep}$

⇒ σ_ε/E (jets) < 3.8%

Sign ~ S/√B ~ (resol)^{-1/2}
 60%/√E → 30%/√E ⇔ +~40% L

Large TPC

- Precision and low X₀ budget
- Pattern recognition

High precision on Si trackers

- Tagging of beauty and charm

Large acceptance

Fwd Calorimetry:

- lumi, veto, beam monitoring

Imaging Calorimetry



H. Videau and J. C. Brient, "Calorimetry optimised for jets," in Proc. 10th International Conference on Calorimetry in High Energy Physics (CALOR 2002), Pasadena, California. March, 2002.

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Imaging Calorimetry

Imaging Calorimeters 1000× current granularity

- wrt LHC: data rate **>>** but embedded electronics
- Pattern recognition see Naomi van der Kolk Poster

Needed R&D:

- Dimensioning, Mechanics (uniformity), Sensors, Electronics, VFE, Power Consumption, Thermal dissipation & uniformity
- Iterative construction & test of Prototypes
- Detector & Integration
 - Optimisation : Physics vs cost, services (PP, cooling)

Dedicated SW tools for PFA:

Difficulty : perf in JER = HW \otimes SW

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SiW ECAL: Physics & Technological prototype

Physics prototype: 2005-2011

PFA proof of concept with comparison to MC (PandoraPFA etc.)

Electronics outside

- 1cm x 1cm pixels
- full 30 layers

(used for PAMELA sat.)





16.5%(stochastic) 1–2% (constant) obtained with 1–45 GeV e⁻/e⁺ at 2006/2008 BT

Technological prototype



Embedded electronics

- SKIROC2 analog/digital ASICs
 - auto-triggered, zero suppr., PP
- pixels 5×5mm²

Assess the feasibility

Establish procedures and develop test benches for mass production

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The SiW-ECAL of ILD



On going R&D

- Thermic & Mechanical studies
 - Production, Characterisation & Monitoring
 - Thermic simulation & cooling
- Assembly: Quality tests & preparation of large production
 - VFE, PCB's, ASU's
 - TB, Cosmics, Charge injection
- Wafers:
 - Guard Ring Studies → CALIMAX program
 - Characterisation
 - Charge injection by Laser
- DAQ (see Frank Galstaldi talk's)
- Power consumption (not here)
- Optimisation: Cost \rightarrow reduction of radius

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ECAL : Composite Structure (barrel)

- Carbon Fiber + Tunsgten
 - Prod : dec 2011 (5 yrs of R&D)
 - 600kg, 15 layers
- 15 alveoli produced, 1 faulty
- 1 equipped with Fiber Bragg-Gratted (FBG)
 - ⇒ Comparison calculation and measurement
- Assembling mould
 - Cooking in autoclave
- Metrology
 - Minor on-side deformation

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ILD SIW ECAL R&D | TIPP'14, Amsterdam, June 02-06 2014





Vérification des paramètres du modèle en comparant la flèche FBG3 mesurée et simulée

7/37



ECAL structure

Barrel: 5 octogonal wheels

- $R_{min} = 1808 \text{ mm};_{m}R_{ax} = 2220$
- Width = 940mm

End-caps: 4 quarters

& tests

Vincent.F

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 $- \varphi_{min} = 800 \text{ mm}$

Carbone / Tunsgten structure

 filled with Si or scintillators (option MAPS/DECAL)

Extensive mechanical simulation

TOTS TOTS TOTS Ton Fixing line (3 rails)

 $e_{max} = 0.07 \, mm$

Barrel Endcap1 Endcap2 **End-cap** sector 732 732 5 columns *Compared with barrel stave*

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Evolution of skin thickness for Endcaps

Correlation of FEA simulations / shearing tests of representative structure Problem of bending stress of alveoli skins / evolution of external plies



Influence of modification of external ply thickness on the first main constraint of external and internal walls If external plies thickness increases => **Impact** on ECAL dead zone => Optimization of deflection values

Tests & simulations to be performed

Displacements	~0.1 mm vs 0.5mm for fatigue shearing tests	
Main contraints	<159 Mpa both	
Shearing constraint	11.5 Mpa vs 6 (1,8/wall) Mpa for shearing tests	

From simulations to shearing tests (ANSYS APDL / SAMCEF / ANSYS ACP)

- •Adapt FEA parameters to simulate the whole structure / shearing results
- •Destructive test on a existing structure (demonstrator -EUDET) / verification of bonded structures
- •Process: increase intercoat adhesion with structural adhesive film
- •Process: obtaining reliable thicknesses of walls (specific long moulds, tooling development) / Draping optimization
- •Reliability tests: good & uniform impregnation of parts, good compacting
- •Resistance of End-Caps to earthquake
- •"Mass" production conception (ply book enhancement, tooling, process)

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ECAL End-Caps: shearing tests



Monotonic shearing test

Destructive tests with charge & discharge cycles / hysteresis & weakening of the structures (resin) during repeated stresses



Fatigue + Progressive shearing cycles

 $\begin{array}{l} \mbox{Reduction in stiffness} \\ \mbox{predictable during integration} \\ (G\# 85 \mbox{ MPa to 74 \mbox{ Mpa}}) \\ \mbox{Stay} < \Delta x = 0.35 \mbox{ mm (mechanical limiters) or} \\ \mbox{Increase No. of envelope folds (/ seism)} \\ \mbox{Max. admissible flexion value of slabs to be confirmed} \end{array}$

To be continued in 2014

safety factor: s = 3.2 with respect to the stress induced / largest module

(2,5m-25,5 kN) to be improved / "seismic issues" ILD'13 meeting in Cracow



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Fasting system (on HCAL)



Mechanical structure of frames

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Thermic Studies & Cooling





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SLAB Assembly: full chain

R&D for "mass production" and QA

- Quality tests & preparation of large production
- Modularity → ASU & SLABs
 - Choice of square wafers
 (≠ from hex: SiD, CMS HGCAL)
- Numbers ($R_{ECAL} = 1,8 \text{ m}$, $|Z_{Endcaps}|=2,35 \text{ m}$) (likely to be reduced by 30–40%)
 - Barrel modules: 40 (as of today all identical)
 - Endcap Modules: 24 (3 types)
 - Slabs = 6000 (B) + 3600 (EC) = 9600
 - many ≠ lengths
 - ASUs = ~75,000
 - Wafers ~ 300,000 (2500 m²)
 - VFE chips ~ 1,200,000
 - Channels: 77Mch

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U layout of a long slab

ASIC tests w/ testboards

SKIROC2 VFE Chip

- 64ch readout/chip
- preamp + 2 shapers
- Auto-trigger
- 15 cell analog memory
- 14 bit ADC

SKIROC2 test board

- No detector, input holes
- Analog/digital tests
- Automated test software
 with Labview ⇒ caracterisation
- Small crosstalk found



See Ch. de la Taille's talk

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ECAL : FE Boards

Tests of (early) FEV7 CIP et COB PCB

- Thin option (COB) not (yet) solved
 - \Rightarrow Choice of going to U shape of
- "Adaptator" board
 - Interface to cooling
 - Buffer for power pulsing
 - with super-capacitors (super-C)
 - Connexions tested in strong B field
 - → DESY (02/2013): no effect





FEV 8→9→10

FEV8



QFP SKIROC2

- 4 chips/board (256ch)
- used in 2012/13 BT
- 10 slabs exist

FEV9



Mechanical model, no chips



Straight and snake lines

16 BGA SKIROC2

Good flatness (< 0.5 mm)
Electronics test are on-going
4 FEV9 will be interconnected for long slab test.

FEV10

will be used for 2015 BT

COP option:

new production (in Korea) soon



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Flexible FE test bench

2.0 - Setup option with support of test electric probes for connecting WAFER to FEV

- Realize an assembly with removable wafer in order to acquire cosmic data. This assembly will test the entire acquisition chain (Wafer-FEV-SMBV4-DIF-GDCC-CCC-PC-Software) before the wafer gluing operation. The first test was realized last week



Flexible benches for R&D

CALICE DAQ2 Acquisition System

Franck Gastaldi's talk

(DAQ Session)

- Qualification of PCB before assembly
- Basis for later mass test

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Assembly 1: Gluing

Toward semi-automatic gluing of 4 wafers on every PCB:

- Constraints on the PCB geometry have been identified:
 - Flatness
 - Parallelism of the edges
 - Uniform height of the ASIC soldered on the board

9 sensors has been glued with the robot: used at 2012–13 beam tests

The leakage currents measured before and after the gluing process are similar.



Recent improvements

- Use of specific pumps for dry and clean vacuum
- Careful cleaning of PCB
- New positioning of the glue dots for the external pads, to avoid shortcircuits.

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Next steps

- Software for automated positioning and alignment
- Combine gluing and positioning robots
- Move to clean room
- Test the gluing of 4 sensors on a single PCB
 - already done with 4 glass tiles on FEV9
- Completing the Quality Insurance
 - Procedure
 - Metrology of PCB
 - Transportation from/to other labs



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Both robots assembled



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Assembly bench

Development of a set of specifications to assure proper assembly of four wafer ASUs

- Tolerances of PCB, H or U board
 - Example : Mechanical stress on wafers during interconnections
- First set end spring 2014
- Revision/Scrutinisation of assembly tools
 - Development and validation of assembly bench, 'easy' reproducibility
 - Combination of ASU positioning and interconnection



Interconnection station

Assembly station



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Assembly of slabs: example of systematic studies

Pressure test on ASU (FEV8_Glass) with soldier iron for interconnection



Wafers:

Key elements of detector

- Basic unit for the size of the detector
- (Most expensive part too)

Guard Rings

- Alternative designs
 - segmented, "edgeless"
- Complete characterisation of sensors
 ⇒ link to & test variety of producers
- Work in CALIIMAX-HEP French ANR in relation with Kyushu/Hamamatsu

Test of Silicon sensors

- Test different HPK designs: C-V, I-V.
- Laser tests: xtalk via GR.
- Plans: Irradiation tests (γ, n)

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See Tatsuhiko Tomita's Poster

From physics prototype test beams



"Square events"

 cross talk between guard rings and pixels



Basic sensor study

Two batches of Hamamatsu sensors





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Laser study with guard rings (baby wafers)



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Laser study (full wafer)

... fires in Si detachable sensor in the gap between aluminium contacts



- Laser characteristics: = $1056 \pm 5 \text{ nm}$, 200 kHz, < 1 nsec pulse
 - ~ 700 MIP signal. Intrinsic silicon absorption length at 300 K: \approx 0.8 mm.
- Adapted Flexible FE testbench setup
 - 1024 spring contacts of 5 mm length between pixels and PCB pads.
- "Standard Acquisition chain"
- Hamamatsu silicon sensor:
 - 16x16 pixels of 5.5×5.5 mm², thickness 330 $\mu m.$

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 gap 2, laser 100%

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Preliminary results:

- Not all springs installed and not all have contacts, about half is operational.
- Clear signals in connected pixels.
- A typical induced signal is ~0.4...0.5% per outer pixel side ×2 for corner, ×2 in case of 4 connected pixels.
- To be improved: high noises (set-up), PCB bending.

Working well but "Room for improvement"

from Charge injection, cosmics, test beam

Post triggering of BX+1, BX+2 at many channels

- in \leq 50% of events
- improved by decoupling capacitor but still exists
- Noisy channel ~10%? (PCB routing?)
- External trigger not working
 - Auto trigger mode only
- TDC (maybe too noisy)
- ~ 5% nonlinearity at ~1 MIP level

Many of them will be improved/solved in FEV9 & 10

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Charge injection,



Optimisation: Cost vs performance

AHCAL (Lol)

-- 45 GeV iets

AHCAL (recent

45 GeV jets

Multi-parametric optimisation

- Using full simulation & PFA rec (PandoraPFA) on
 - jets, tau's, gamma
 - over full E range
- options mix: HCAL's
- Main cost driver:
 - Badius of Tracker
 - Number of layers
 - Wafers & structural gaps,
 - Electronics thickness
 - Resilience: allowable failure rate (channel, chips)
- Reduction of
 - Radius $(1,8m \rightarrow 1,4m)$
 - Number of layer $(30 \rightarrow 25)$

seems reasonable for minor perf. degradation for ~30-40% cost reduction

2.5

sDHCAL

1200

RMS90/E[%]

3.5

45 GeV jets 100 GeV jets

180 GeV jets

250 GeV jets

1300

To be assessed with full simulation around new design

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Cont = 1600 mm

Conclusion & Plans

Complex task of learning & optimisation

- Every aspects intertwined:
 - Electronics performance (including power budget), Thermic, Mechanics, Compactness, reconstruction SW ... within Physics performances & Cost "envelop"
 - Mass production & Quality Aspects at every stage
- Long Iterative learning procedure
- Wafer design and characterisation crucial (Cost), contact with producers (experience buildup)
- 2014: Solutions found for every aspects \rightarrow "full" technological prototype in 2015
 - Short slabs (1 ASU) in Fall
 - Tower of 18×18 cm² + 1 Long slab (6-7 ASUs) in 2015
- TB with HE electrons: stand-alone & combined (SDHCAL, AHCAL slabs): end 2015-2016
 - verification of response, electronics in beam
- 10 yrs of R&D \rightarrow applications to future detectors: ILD but also
 - HL upgrade of the CMS endcap phase2 (HGCAL option)
 - Future circular colliders (TLEP/FCC, CEPC); heavy ions fix exp.
 - Adaptation needed (power consumption \rightarrow lower granularity)
 - Si radiation resistance

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Extras

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Physical prototype



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Optimization of "Hybrid"





RMS90(Ej) / Mean(Ej) [%]

	45GeV	100GeV	180GeV	250GeV
SiECAL	3.70	2.86	2.88	2.96
Hybrid [Si16+Sc14]	3.66	2.90	2.90	3.00
Double	3.69	2.92	2.91	3.02
Single	3.73	2.90	2.87	3.00
ScECAL	3.70	2.97	3.05	3.18

We will move to more strategic way...

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Current structure of end caps



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ILD : intégration

Intégration → DBD (fin 2012)

- Développement d'outils de CAO
- EDMS aussi utilisé coté machine
- $\leftrightarrow LAL, DESY$

Calorimètres

- ECAL (\leftrightarrow LPSC, LAL)
- DHCAL (↔ IPNL, CIEMAT)

Cohérence ↔ simulation

Développement d'un modèle réaliste

- Zones mortes
- services (cooling, power)
- Supports

Critique pour le DBD

(très visible au meeting IWLC'2010)

1ère version de ILD ~ complète

→ production MC de masse

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Study from the power source to the global cooling







Thermal simulation and test on Slab



Heat exchanger

Simulation and test on different type of heat exchangers





Global cooling True scale leak less loop



Reminder FEV_COB



- Interface board with Chip On Board - Assures <u>compact</u> calorimeter

- Not trivial specs

Ultrathin : 9 layers with thickness of about 1.2mm Deviation of total planarity of about 0.5 mm (3mm is industrial standard)

However it's now there in a first version

- Design and routing OMEGA/LAL
- Fabrication end of 2012
- Metrology at LAL
- Chips mounted beginning of 2013 by CERN bonding lab
- First tests in summer 2013 at LAL

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Cooperation with EOS





- Korean company EOS has declared to be ready to produce the PCB
 Relaxed constraints on the thickness 1.2mm -> 1.5mm
- Technical discussion ongoing via mail but production is imminent
- Plans to assure entire PCB assembly in Korea
 - PCB production
 - ASIC bonding
 - Encapsulation

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